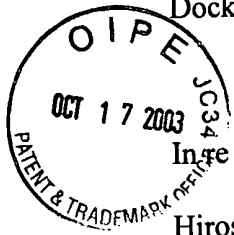


Docket No.: 50090-306

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**



In re Application of

Hiroshi TOBIMATSU, et al.

Serial No.: 09/910,824

Filed: July 24, 2001

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING  
PASSIVATION FILM AND BUFFER COATING FILM

: Customer Number: 20277  
:  
: Confirmation Number: 3928  
:  
: Group Art Unit: 2823  
:  
: Examiner: LEE, Hsien Ming  
:

**PETITION FOR EXTENSION OF TIME**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated June 18, 2003, now due to expire September 18, 2003, be extended for one month(s) and set to expire on October 18, 2003.

Please charge the extension fee of \$110.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

10/20/2003 HDEHES1 00000046 500417 09910824  
02 FC:1251 110.00 DA

*Arthur J. Steiner* 42,988  
/s/ Arthur J. Steiner  
Registration No. 26,106

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Date: October 17, 2003